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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO		
10/690,503	10/23/2003	I-Cherng Chen	3313-1048P	3313-1048P 6047		
2292	7590 08/23/2004		EXAM	EXAMINER		
BIRCH STEV PO BOX 747	WART KOLASCH &	LAM, CATHY	LAM, CATHY FONG FONG			
	RCH, VA 22040-0747	ART UNIT	PAPER NUMBER			
	,		1775			

DATE MAILED: 08/23/2004

Please find below and/or attached an Office communication concerning this application or proceeding.

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		Applicatio	n No.	Applicant(s)	7,0			
Office Action Summary		10/690,50	3	CHEN ET AL.				
		Examiner		Art Unit				
		Cathy Lan)	1775				
Period fo	The MAILING DATE of this communication reply	on appears on the	cover sheet with the	correspondence addi	ress			
THE - Exte after - If the - If NO - Failt Any	MAILING DATE OF THIS COMMUNICATION OF THIS COMMUNICATION OF THIS COMMUNICATION OF THIS COMMUNICATION OF SIX (6) MONTHS from the mailing date of this communication of the period for reply specified above is less than thirty (30) days to period for reply is specified above, the maximum statutory pure to reply within the set or extended period for reply will, by reply received by the Office later than three months after the need patent term adjustment. See 37 CFR 1.704(b).	ION. CFR 1.136(a). In no eversion. To a reply within the statust period will apply and will statute.	nt, however, may a reply be fory minimum of thirty (30) d expire SIX (6) MONTHS fro cation to become ABANDON	timely filed ays will be considered timely, om the mailing date of this com NED (35 U.S.C. § 133).	munication.			
Status								
1)	Responsive to communication(s) filed on							
2a)□		This action is no	n-final.	•				
-	Since this application is in condition for allowance except for formal matters, prosecution as to the merits is							
,—	closed in accordance with the practice under <i>Ex parte Quayle</i> , 1935 C.D. 11, 453 O.G. 213.							
Disposit	ion of Claims				~			
5)□ 6)⊠ 7)□	Claim(s) <u>1-31</u> is/are pending in the applicate 4a) Of the above claim(s) <u>1-19</u> is/are with Claim(s) is/are allowed. Claim(s) <u>20-31</u> is/are rejected. Claim(s) is/are objected to. Claim(s) are subject to restriction as	drawn from consi						
Applicat	ion Papers							
10)⊠	The specification is objected to by the Exact The drawing(s) filed on <u>23 October 2003</u> is Applicant may not request that any objection to Replacement drawing sheet(s) including the country the oath or declaration is objected to by the country of the oath or declaration is objected to by the country of the oath or declaration is objected to by the exact that are objected to be	s/are: a)⊠ acce to the drawing(s) be correction is require	e held in abeyance. So	see 37 CFR 1.85(a). objected to. See 37 CFF	R 1.121(d).			
Priority (under 35 U.S.C. § 119							
12)⊠ a)	Acknowledgment is made of a claim for fo All b) Some * c) None of: 1 Certified copies of the priority docu 2. Certified copies of the priority docu 3. Copies of the certified copies of the application from the International Besee the attached detailed Office action for	ments have beer ments have beer e priority docume Bureau (PCT Rule	received. received in Applica nts have been recei 17.2(a)).	ation No ved in this National S	tage			
Attachmen	ut(s)							
1) 🔯 Notic	ce of References Cited (PTO-892)		4) 🔲 Interview Summa	ry (PTO-413)				
2)	ce of Draftsperson's Patent Drawing Review (PTO-94 mation Disclosure Statement(s) (PTO-1449 or PTO/Ser No(s)/Mail Date <i>Mar. 02, 2004</i> .	,	Paper No(s)/Mail	• 1	.52)			

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- 1. Restriction to one of the following inventions is required under 35 U.S.C. 121:
 - Claims 1-19, drawn to a method of making a material with a surface nanometer functional structure, classified in class 423, subclass 593.
 - II. Claims 20-31, drawn to a material with a surface nanometer, classified in class 428, subclass 621.

The inventions are distinct, each from the other because of the following reasons:

- 2. Inventions I and II are related as process of making and product made. The inventions are distinct if either or both of the following can be shown: (1) that the process as claimed can be used to make other and materially different product or (2) that the product as claimed can be made by another and materially different process (MPEP § 806.05(f)). In the instant case the product as claimed can be made by a different method such as by plasma deposition. The process as claimed can be used to make a different product such as semiconductor crystalline structure.
- 3. Because these inventions are distinct for the reasons given above and have acquired a separate status in the art as shown by their different classification, restriction for examination purposes as indicated is proper.
- 4. During a telephone conversation with Atty: Joe McKinney Muncy on August 19, 2004 a provisional election was made with traverse to prosecute the invention of group I, claims 20-31. Affirmation of this election must be made by applicant in replying to this Office action. Claims 1-19 are withdrawn from further consideration by the examiner, 37 CFR 1.142(b), as being drawn to a non-elected invention.

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5. Applicant is reminded that upon the cancellation of claims to a non-elected invention, the inventorship must be amended in compliance with 37 CFR 1.48(b) if one or more of the currently named inventors is no longer an inventor of at least one claim remaining in the application. Any amendment of inventorship must be accompanied by a request under 37 CFR 1.48(b) and by the fee required under 37 CFR 1.17(i).

Claim Rejections - 35 USC § 112

6. Claims 21, 25, 27-28 are rejected under 35 U.S.C. 112, second paragraph, as being indefinite for failing to particularly point out and distinctly claim the subject matter which applicant regards as the invention.

In claim 21, it is vague and indefinite as to what "a nanometer material" is referring to?

In claim 25, "the functional later" is indefinite.

In claim 27, there is lack of antecedent basis for "the substrate surface".

Claims 27 and 28 are structurally indefinite.

Claim Rejections - 35 USC § 102/103

7. The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

- (b) the invention was patented or described in a printed publication in this or a foreign country or in public use or on sale in this country, more than one year prior to the date of application for patent in the United States.
- 8. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:
 - (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and

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the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

9. Claims 20-31 are rejected under 35 U.S.C. 102(b) as anticipated by or, in the alternative, under 35 U.S.C. 103(a) as obvious over Wagner et al (Applied Physics Letters).

Wagner discloses a crystalline growth of a metal alloy from vapor, onto a substrate. The metal alloy after continuous depositing becomes a silicon whisker.

Sil² and gold impurity formed a liquid alloy which was deposited in a small globule onto a silicon substrate, and after continuously depositing the liquid alloy, little by little, a nano-whisker is formed (ie. the nanowire is formed by continuous deposit of the liquid alloy which atop the growing whisker). The liquid alloy resembles the surface nanometer functional structure as claimed by the applicant.

The examiner takes the position that the silicon whisker resembles the nanowires. The nanowires (ie. silicon whiskers) are formed onto a silicon substrate.

The continuous depositing steps resembles the more than one layer of surface nanometer functional structure on the substrate (as in claims 20 & 27).

The examiner also takes the position that the globules are the nanodots and that this liquid alloy is a self-assembling reaction layer.

Since the nanowire is formed by continuous growing of the alloy droplets, it would be obvious that the nanometer functional structure is a homogeneous layer because for one layer to grow onto another layer, they need to have at least the same crystalline lattice structure.

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Any inquiry concerning this communication or earlier communications from the examiner should be directed to Cathy Lam whose telephone number is (571) 272-1538. The examiner can normally be reached on 9am-6pm.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Deborah Jones can be reached on (571) 272-1535. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

Cathy Lam

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Primary Examiner

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cfl August 20, 2004